


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Lin et al.
App. No : 10/815,905
Filed : March 31, 2004
For : INTERFEROMETRIC MODULATION
PIXELS AND MANUFACTURING
METHOD THEREOF
Examiner : Tran, Hoang Q
Art Unit : 2874
Conf # : 9293

CERTIFICATE OF EFS WEB
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I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

August 29, 2008
(Date)


Jeremy R. Pierce, Reg. No. 59,034AMENDMENT AND RESPONSE**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request consideration of the following Remarks in response to the Office Action sent May 30, 2008 ("Office Action").

A Listing of Claims begins on page 2 of this paper.

Summary of Interview begins on page 6 of this paper.

Remarks begin on page 7 of this paper.